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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Leslie G. Fritzemeier et al.      Art Unit : Unknown  
Serial No. : 09/616,810      Examiner : Unknown  
Filed : July 14, 2000  
Title : MULTI-LAYER ARTICLES AND METHODS OF MAKING SAME

Commissioner for Patents  
Washington, D.C. 20231

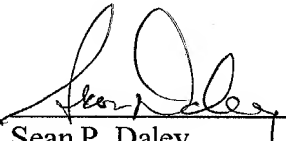
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449, copies of which are enclosed. A copy of a communication from a foreign patent office in a counterpart application is also enclosed.

This statement is being filed before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 8-13-01

  
Sean P. Daley  
Reg. No. 40,978

Fish & Richardson P.C.  
225 Franklin Street  
Boston, MA 02110-2804  
Telephone: (617) 542-5070  
Facsimile: (617) 542-8906

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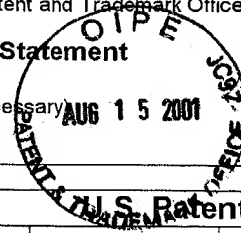
I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, Washington, D.C. 20231.

August 13, 2001  
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05776-095001	Application No. 09/616,810
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Leslie G. Fritzemeier et al.	
		Filing Date July 14, 2000	Group Art Unit



U.S. Patent Documents							
Examiner Initial	Desig. ID	Patent Number	Issue Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	3,763,552	10/09/73	Brown et al.			
	AB	3,985,281	10/12/76	Diepers et al.			
	AC	4,442,396	04/10/84	Hucker			
	AD	4,659,973	04/21/87	Stich			
	AE	4,994,433	02/19/91	Chiang			
	AF	5,038,127	08/06/91	Dersch			
	AG	5,071,828	12/10/91	Greuter et al.			
	AH	5,073,537	12/17/91	Hung et al.			
	AI	5,449,659	09/12/95	Garrison et al.			
	AJ	5,866,252	02/02/99	de Rochemont et al.			
	AK	5,968,877	10/19/99	Budai et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	0 387 525	09/19/90	Europe				
	AM	0 431 782	06/12/91	Europe				
	AN	0 584 410	03/02/94	Europe				
	AO	0 872 579	10/21/98	Europe				
	AP	57075564	05/12/82	Japan (Abstract Only)			X	
	AQ	633 10366	12/19/88	Japan (Abstract Only)			X	
	AR	WO 97/05669	02/13/97	WIPO				
	AS	WO 99/35083	07/15/99	WIPO				

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Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AT	Apicella, M.L. et al., "The Effects of Surface Contamination on the Biaxially Textured Substrate for YBCO Thick Film Deposition", <i>International Journal of Modern Physics B</i> , Vol. 13, Nos. 9&10 (1999) 997-1004

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05770-095001	Application No. 09/616,810
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Leslie G. Fritzemeier et al.	
		Filing Date July 14, 2000	Group Art Unit

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AU	Boffa V. et al., "Laser-ablation deposition of CeO <sub>2</sub> thin films on biaxially textured nickel substrates", <i>Physica C</i> , Vol. 312, (1999), pp. 202-212
	AV	IBM Technical Disclosure Bulletin, "Fabrication of High Temperature Superconducting Films Using Perfluoro-Organometallic Precursors", Vol. 32, No. 5B, October 1989, p. 241
	AW	McIntyre, Paul C. et al., "Effect of growth conditions on the properties and morphology of chemically derived epitaxial thin films of Ba <sub>2</sub> YCu <sub>3</sub> O <sub>7-x</sub> on (001) LaAlO <sub>3</sub> ", <i>J. Appl. Phys.</i> , Vol. 71, No. 4, February 15, 1992, pp. 1868-1877
	AX	Qing He, D.K. et al., "Deposition of biaxially-oriented metal and oxide buffer-layer films on textured Ni tapes: new substrates for high-current, high-temperature superconductors", <i>Physica C</i> , Vol. 275 (1997) pp. 155-161
	AY	Sheth, Atul et al., "Bench Scale Evaluation of Batch Mode Dip-Coating of Sol-Gel LaAlO <sub>3</sub> Buffer Material", <i>IEEE Transactions on Applied Superconductivity</i> , Vol. 9, No. 2, June 1999, pp. 1514-1518
	AZ	PCT Search Report dated June 22, 2001

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